



Crystal structure and morphology of β -HMX in acetone: A molecular dynamics simulation and experimental study

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Abstract. Single crystals of β -Cyclotetramethylene tetranitramine (HMX) were prepared by the solvent evaporation method. The structure was then determined using infrared spectroscopy and single crystal X-ray diffraction. The modified attachment energy (AE) model was used to predict the morphologies of β -HMX in vacuum and in acetone. The morphology and sensitivity of HMX before and after recrystallization were characterized. The results of calculation showed that the (011) and (110) surfaces of β -HMX are of great morphological importance. The predicted β -HMX morphology agreed qualitatively with the SEM result. The sensitivity results show that recrystallization in acetone can effectively reduce the impact and friction sensitivities of β -HMX.

Keywords. β -HMX; single crystal; attachment energy model; crystal morphology; impact sensitivity; friction sensitivity.

1. Introduction

As an excellent high explosive, cyclotetramethylene tetranitramine (HMX) is used for military purposes, as a component of plastic-bonded explosives, as a component of rocket propellants, and as a high explosive buster charge. It has advantage in high density of charges that provide for a higher rate of detonation, for more efficient application.¹⁻³ The detonation performance and specifically the sensitivity of HMX not only have a relationship with the morphology⁴⁻⁷ of the HMX crystals, but also depend on the defects⁸ present in the crystals and the crystal phase.⁹ The attachment stability of growth units (HMX molecules) on each surface of the crystal affects the crystal morphology. In addition, the crystal morphology is also connected with the physical and chemical conditions during growth.¹⁰⁻¹² Therefore, the crystal structure should be closely linked with the growth conditions in HMX crystal morphology research.

At the present time, crystal growth theories and crystal morphology predictions of explosives are being investigated with growing interest.^{13–16} ter Horst *et al.*, added a γ -butyrolactone layer to (200) and (210) crystal surfaces of RDX. They found that the (210) face is morphologically more important than the (200) face, the molecular dynamics simulation results agree well with the observed experimental RDX morphology grown in the solvent γ -butyrolactone.¹⁷ Shi *et al.*, predicted the growth morphology of 2,6-diamino-3,5dinitropyridine-1-oxide (ANPyO) in vacuum and in trifluoroacetic acid solvent by the corrected attachment energy (AE) model. The diffusion coefficient of trifluoroacetic acid molecules on the crystal growth faces has also been analyzed, and the results will be useful for the formulation design of ANPyO.¹⁸ Liu et al., studied the crystal morphologies of 3,4-bis(3-nitrofurazan-4yi) furoxan (DNTF)¹⁹ and 1,1-diamino-2,2-dinitroethylene (FOX-7)²⁰ using the AE model. The impact and friction sensitivities were also tested and discussed for different crystal morphologies. However, as an excellent high explosive, there is little study on the crystal growth theories^{21,22} and crystal morphology predictions of HMX.

In this study, HMX single crystals were prepared and the single crystal structure with low R factor was obtained. In order to study the effect of the interaction between solvent molecules and crystal surfaces on the crystal morphology at the micro scale, the adsorption energy and crystal morphology of HMX in vacuum and acetone were studied by the AE model and molecular dynamics (MD) method (the obtained single crystal being used as the input). The intrinsic and extrinsic factors controlling the morphology were analyzed from the point of view of HMX polarity and the solvent interaction. The single crystal structure can be used as input for molecular simulations for HMX and polymer bonded explosives (PBXs) containing HMX. The morphology

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results can provide a theoretical basis for the selection of solvent in the crystallization process of HMX.

2. Experimental and computational methods

2.1 Preparation and structure determination of HMX single crystal

 β -HMX, C₄H₈N₈O₈, M.W. = 296.18 g·mol⁻¹, is a colorless and transparent crystal. A single crystal of β -HMX was prepared by the solvent evaporation method. Herein, HMX 1 and HMX 2 correspond to the crystals before and after recrystallization from acetone. A crystal, approximately 0.4 × 0.4 × 0.4 mm³, was used for this experiment, and the crystal type being identified from its infrared spectrum. For this, the scattering angles (2 θ) of the most intense reflections having scattering angles in the range of 3° to 65° were measured using an automated Rigaku AFC-6 4-circle diffractometer with MoK α radiation monochromated using a pyrolytic graphite plate.

2.2 Crystal morphology predicted by AE model

The AE model of crystal growth was developed on the basis of the periodic bond -chain (PBC) model. The PBC model assumes that, (i) the time needed for bonding to the crystal surface is inversely proportional to the bonding energy, (ii) the crystal growth rate is proportional to the bonding energy, (iii) the crystal is composed of PBC, and (iv) the fastest crystal growth direction is the direction of the strongest bonds. In the AE model, by analyzing the center-to-plane distance assigned to the dominant crystal surface, crystal morphologies can be obtained, and the center-to-plane distance assigned relates to the relative growth rate. The attachment energy (E_{att}) is the energy released by adding a growth slice to a growing crystal surface.^{19,23} E_{att} can be calculated as follows:

$$E_{\rm att} = E_{\rm latt} - E_{\rm slice} \tag{1}$$

Here, the slice energy (E_{slice}) is the energy released by growing a crystal slice with a thickness of d_{hkl} , and the attachment energy (E_{att}) being the energy released by attaching a slice to the crystal surface. The sum of the two is the lattice energy (E_{latt}). R_{hkl} is the growth rate of (hkl) face of HMX in vacuum and is proportional to the attachment energy of the crystal.

$$R_{\rm hkl} \propto E_{\rm att}$$
 (2)

As the attachment energies for acetone molecules on the different growth faces are different, acetone is important in the crystal growth process. The stronger the adsorption, the easier is the solvent layer formation on the crystal-solvent interface. Acetone will limit the growth of the crystal. Defining $E_{\rm int}$ as the crystal-acetone interaction energy, it can be calculated using the following formula:

$$E_{\rm int} = E_{\rm tot} - E_{\rm surf} - E_{\rm solv} \tag{3}$$

Here, E_{tot} is the sum of crystal surface energy and acetone layer energy, E_{surf} is the energy of crystal surface, E_{solv} is the energy of the acetone layer.

Considering the influence of the acetone layer, the calibration factor E_s for vacuum attachment energy is introduced, which describes the binding energy of solvent on the (hkl) face of HMX crystal. It can be calculated as follows:¹⁹

$$E_{\rm s} = E_{\rm int} \times \frac{A_{\rm acc}}{A_{\rm cell}} \tag{4}$$

Here, A_{acc} is the acetone-accessible area of the crystal face in the unit cell.^{14,19} A_{cell} is the total crystal face area along the (hkl) plane.

The acetone attachment energy can be described using the formula:

$$E'_{\rm att} = E_{\rm att} - E_{\rm s} \tag{5}$$

The growth rate of each crystal face (R'_{hkl}) is proportional to the acetone attachment (E'_{att}) energy of the crystal (as shown in eq. 6), which is given by Hartman in the modified morphology theory.²⁴

$$R'_{\rm hkl} \propto \left| E'_{\rm att} \right|$$
 (6)

2.3 Molecular dynamics simulation

The β -HMX original cell was built according to the single crystal X ray diffraction results and the forceit module²⁵ was applied to optimize the original structure. Then, the growth morphology in vacuum was predicted by the AE model, to obtain the main growth faces (hkl). A 3 × 3 × 3 super cell was built based on the optimized original cell and cutting crystal along (011), (110), (020), (11–1) and (101) faces, respectively.

A 20 Å vacuum layer was added on each crystalline surface of β -HMX. Then, the solvent-accessible area was calculated using the Atom Volumes and Surfaces tool of the MS software,²⁶ which creates a field that can characterize the geometry and solvent interaction of an atomistic structure in a variety of ways.²⁷ For the Connolly task in the Atom Volumes and Surfaces tool, there is a field whose value at each point in space corresponds to the depth in the nearest Connolly probe of a given radius, as it rolls over the van der Waals surface of the atomistic structure.²⁸

The amorphous cell module was applied to build the solvent layer containing 200 random acetone molecules with a target density of $0.788 \text{ g} \cdot \text{cm}^{-3}$. The size of the periodic cell for the acetone layer must be consistent with the size of the HMX periodic cell. Further, the Andersen thermostat was applied to carry out geometry optimization and MD simulation in the NPT ensemble for acetone molecules.

The adsorption models for HMX surface-acetone were built from a HMX crystal layer and an acetone layer. The acetone layer was placed along the c axis on the HMX surface and a vacuum upto a height of 30 Å above the acetone layer. COMPASS force field²⁹ was selected. Optimizing the initial configuration of HMX-acetone and annealing (300– 500 K, 10^4 steps) of the HMX-solvent configuration were used to eliminate unreasonable conformations. The configurations were taken after annealing for the MD simulation at constant pressure and temperature (NPT) ensemble at 298 K and 10^5 Pa for 500 ps. Andersen thermostat was used.^{30–33}

2.4 Recrystallization experiments

HMX crystals were recrystallized in acetone by solvent evaporation. Recrystallization experiments were carried out in new 50 mL volumetric flasks at room temperature. The flasks were sealed with plastic film with several holes and left to stand for about a week to obtain HMX crystals.

2.5 Sensitivity test

Chinese GJB772A-97 method 601.1 was used to test the impact sensitivity.³⁴ The samples were sandwiched between two smooth hard surfaces and impacted by a drop hammer falling freely from a fixed height. The explosion probability was tested to characterize the impact sensitivity. The weight of the hammer was 10 kg, and that of the explosive sample was 50 mg. The experimental device is shown in Figure 1. The drop hammer fell freely from a height of 25 cm. When there was a phenomenon of sound, light, smoke, sample discoloration, traces on the surface of the impact pillar, or smell of the gaseous products of decomposition or explosion, it was judged to be an explosion. Otherwise, there was no explosion. The explosive probability of a set of tests (25 samples) was calculated as follows:

$$P = \frac{X}{25} \times 100\% \tag{7}$$

Here, P is the explosion probability, and X is the number of explosions for 25 samples.

Friction sensitivity was tested according to Chinese GJB772A-97 method 602.1. The samples were sandwiched between two smooth hard surfaces, loaded at constant pressure and external force of sliding friction. The explosion probability was tested to characterize the friction sensitivity. The WM-1 friction sensitivity instrument was used which is shown in Figure 2. The gauge pressure was 3.92 MPa, and



Figure 1. The experimental device for impact explosion test.



Figure 2. The experimental device for friction test for explosion.

the explosive sample weight was 20 mg. The swing angle was set as 90° , and then the impact hammer of the pendulum was released, and the top slide pillar moves a distance. When there was a phenomenon of sound, light, smoke, sample discoloration, traces on the surface of impact pillar, or smell of the gaseous products of decomposition or explosion, it was judged to be an explosion. Otherwise, there was no explosion. The explosive probability of a set of tests (25 samples) was calculated by eq. 7.

3. Results and Discussion

3.1 *Single crystal structure*

An infrared spectrum (Figure 3(a)) was taken to determine the crystal type of the prepared HMX sample. There is no peak in the range of 700–750 cm⁻¹, therefore the sample is β -HMX.^{35,36} There is no phase transition in the preparation process of the single crystal of HMX. The single crystal structure of β -HMX is shown in Figure 3(b). β -HMX crystallizes in the orthorhombic space group P2(4)/n. The dimensions thus obtained are a = 6.548(2) Å, b = 11.041(4) Å, c = 7.369(3) Å, β = 102.738(5)°, Z = 2, V = 519.6(3) Å³, and the observed density is D_c = 1.893 g·cm⁻³. The final leastsquares parameters for the structure of HMX are shown in Table 1.

In order to further study the structure of β -HMX crystal, the obtained structure was compared with the structure used most widely in molecular simulations (structure B). The identity number of structure B in the CCSD database is OCHTET12, for which R factor is the lowest in the database. As shown in Table 2, there are differences between structure A and structure B. First, "c" of structure A is 7.369 Å, while "c" of structure B is 8.700 Å; second, " β " of structure A is smaller than structure B; third, structure A and structure B belong to different space groups. Most importantly, the R factor of structure A is smaller than that for structure B, which suggests that the accuracy of structure A is higher



Figure 3. (a) Infrared spectrum of β -HMX; (b) Packing of the HMX molecules in crystal lattice.

Table 1. Final least-squares parameters for the structure of HMX.

Atom	Х	У	Z	U(eq)	
C(2)	0.1903(2)	0.8855(4)	0.9464(2)	0.028(4)	
C(4)	-0.0222	1.0658(4)	0.7826(4)	0.028(4)	
N(4)	0.1424(2)	0.9756(4)	0.7947(4)	0.030(4)	
N(3)	0.0184(4)	0.8775(4)	0.10380(4)	0.026(4)	
N(4)	-0.1401	0.7973(4)	0.9684(4)	0.031(4)	
N(2)	0.3009(2)	0.9987(4)	0.7068(4)	0.033(4)	
O(4)	-0.2706	0.7803(4)	1.0621(4)	0.043(4)	
O(4)	0.2701(2)	1.0716(4)	0.5779(4)	0.049(4)	
O(3)	-0.1406	0.7533(4)	0.8161(4)	0.048(4)	
O(2)	0.4628(4)	0.9399(4)	0.7609(2)	0.047(4)	

x, y and z are the refined atomic coordinates in Å of the x, y and z axis, respectively. U(eq) is the equivalent displacement parameter. Equivalent displacement parameters are in $Å^2$.

and the difference with the real structure is less. In the subsequent calculation, the measured single crystal structure (structure A) will be taken as the original configuration. The differences between structure A and structure B can be caused by several reasons. The differences could be related to particle size effects, orientation of the HMX crystal and the test conditions (the 2-theta range $(3-65^\circ)$ may be too limited). All of these factors can affect the single crystal structure of HMX. We will study the specific reasons in the future work.

 Table 2.
 The single crystal structure of HMX by experiment and from CCSD database.

Parameters	Structure A (exp)	Structure B (CCSE	
a(Á)	6.548(2)	6.540	
b(Å)	11.041(4)	11.050	
c(Á)	7.369(3)	8.700	
β (°)	102.738	124.30	
$\rho (g \cdot cm^{-3})$	1.893	1.8937	
Space group	P21/N	P21/C	
Crystal system	Monoclinic	Monoclinic	
Z	2	2	
R-factor/%	3.5	5.9	

3.2 Growth morphology of HMX in vacuum

The growth morphology of HMX in vacuum predicted by the AE model is shown in Figure 4. The morphology of HMX in vacuum is similar to a soccer ball and the crystal habit parameters of the main stable crystalline surfaces of HMX are listed in Table 3. The morphologically dominant faces are (011), (110), (020), (10–1) and (101), which account for 60.14, 30.90, 6.16, 1.76 and 1.04% of the total surface area, respectively. Among all the faces, the morphological importance of (011) is strongest for its largest d_{011} (6.02 Å) and largest face area (accounting for 60.14% of the total area). The attachment energy of (011) is -112.07 kJ·mol⁻¹. The (101) face has the weakest morphological importance, accounting for 1.04% of the total face area.



Figure 4. The predicted morphology of HMX by the AE model in vacuum.

3.3 Growth morphology of HMX in acetone

Before understanding the interaction between the HMX crystal surface and acetone molecules, it is meaningful to study the crystal surface of HMX. The molecular arrangments of different crystal surfaces are displayed in Figure 5. The surfaces of (110) and (10–1) are very rough. Surfaces (011), (020) and (101) are flat, especially (101). Paramater "S" is introduced to describe the surface characteristics of the HMX crystal, which is the ratio of solvent accessible area to the corresponding

Table 4. The parameter S values for the crystal habitsurfaces of HMX.

(h k l)	(0 1 1)	(1 1 0)	(0 2 0)	(10-1)	(1 0 1)
$ \begin{array}{c} A_{\rm acc} \\ A_{\rm hkl} \\ A_{\rm box} \\ S \end{array} $	115.58	134.55	65	143.32	129.12
	86.92	94.60	48.25	96.19	120.13
	782.28	851.34	434.27	865.70	1081.37
	1.33	1.42	1.35	1.49	1.07

All areas are in $Å^2$. The solvent-accessible area of (h k l) faces in the unit cell. The surface area of the corresponding (h k l) face.

surface area. The calculated values of A_{acc} , A_{hkl} and "S" are shown in Table 4. As shown in Table 4, all "S" values are in the range of 1–1.5. However, the differences of "S" values for the HMX crystal faces is very great. With the largest "S" value (1.49), the (10–1) face is very rough, which can promote the adsorption of solvent molecules. However, the "S" value of the (101) face is only 1.07. This small "S" value means morphological smoothness which does not facilitate to the adsorption of solvent. In addition, all 5 crystal faces have many of nitro groups exposed on the surface, whose polarity is very strong. The exposed nitro groups facilitate to the adsorption of acetone (Figure 6).

(h k l)	Multiplicity	$d_{ m hkl}$	$E_{\rm att}$	R _{hkl}	Total face area/%
(0 1 1)	4	6.02	-112.07	1.00	60.14
$(1 \ 1 \ 0)$	4	5.53	-167.32	1.49	30.90
$(0\ 2\ 0)$	2	5.52	-162.23	1.45	6.16
(1 0 - 1)	2	5.40	-219.37	1.96	1.76
(1 0 1)	2	4.32	-186.85	3.26	1.04

Table 3. The selected crystal habit parameters of HMX crystals in vacuum, predicted by the AE model.

All energies are in $kJ \cdot mol^{-1}$, Interplanar distances are in Å.



Figure 5. The molecular arrangement of different HMX crystal faces repesented by Connolly surfaces.³⁸



Figure 6. The equilibrium conformation HMX (110) face-acetone.

In order to understand the adsorption characteristics of acetone on different cystalline surfaces of HMX, the adsorption behavior was studied. Taking the (110) face as an example, acetone molecules and HMX molecules were found to be close together in the equilibrium conformation of the HMX-acetone system after performing molecular dynamics. It suggests that there are strong interactions between the acetone layer and the (110) face of HMX due to the strong polarity of acetone and the strong polarity of nitro groups exposed on the (110) face of HMX. The relative binding stength of acetone on different surfaces of HMX is as follows: (10-1) > (101) > (110) > (011) > (020). Besides the binding energy between the crystal surfaces and acetone, the contribution of van der Waals force and electrostatic force were calculated. As displayed in Table 5, the contribution of van der Waals force to the total binding energy of acetone layer with (011), (110), (020), (10-1) and (101) is 58.78, 55.44, 53.50, 55.42 and 63.85%, respectively; the contribution of electrostatic force on the binding energy of an acetone layer with (011), (110), (020), (10-1) and (101) is 23.09, 32.41, 33.23,

 Table 5.
 The binding energy between HMX crystalline surfaces (hkl) and acetone.

Energy	Energy		$E/(kJ \cdot mol^{-1})$					
types	source	(011)	(110)	(020)	(10-1)	(101)		
E _{total}	E	-66394.91	-66000.07	-39609.26	-66151.13	-66161.58		
	vdW	-2780.58	-2778.07	-2760.85	-3102.14	-3241.59		
	Eelec	-72191.23	-72055.26	-44087.38	-72233.91	-72114.32		
E _{sur}	E	-52498.38	-51868.74	-26129.01	-52061.52	-51902.81		
	vdW	-36.28	196.88	49.78	193.03	67.46		
	Eelec	-56170.38	-55922.42	-27962.28	-56073.86	-55824.82		
$E_{\rm solv}$	E	-13351.71	-13376.58	-12998.71	-13018.65	-13276.35		
	vdW	-2424.06	-2556.49	-2553.02	-2701.66	-2681.76		
	Eelec	-15895.08	-15888.22	-15965.09	-15804.58	-15975.75		
E _{inter}	E	-544.82	-754.74	-481.54	-1070.96	-982.42		
	vdW	-320.23	-418.46	-257.61	-593.52	-627.29		
	Eelec	-125.78	-244.61	-160.01	-355.48	-313.75		

Note: E_{total} is the single-point energy of the equilibrium structure; E_{sur} is the single-point energy of HMX; E_{solv} is the single-point energy of acetone in the equilibrium structure; E is the total energy of each structure; vdW is the energy of each structure obtained by the vdW interaction; E_{elec} is the energy of each structure obtained by electrostatic interaction.

33.19 and 31.94%, respectively. Therefore, HMX crystal surfaces interact with acetone layers almost in the same way, mainly *via* the van der Waals force.

After the analysis of the roughness of HMX crystal surfaces and the HMX-acetone interaction, the parameters for the crystal growth of HMX in acetone have been calculated. For acetone, the (10-1) face has the greatest solvent attachment energy E_s (-1070.96 kJ·mol⁻¹), and the (011) face has the lowest solvent attachment energy, only $-544.82 \text{ kJ} \cdot \text{mol}^{-1}$. The order of the solvent attachment energy for different crystal faces is as follows: $(10-1) > (101) \approx (110) > (011) > (110)$. The result suggests that the interaction intensity of the (10-1) face with actone is greatest and the solvent adsorption capability of the (10-1) face is strongest, and the solvent adsorption capability of the (110) face is weakest. The adsorption capacity is mainly decided by two factors, the first is the number of the exposed polar groups on the crystal surface, and second is the roughness of the crystal surface (Table 6).

From the previous theory, interaction with an acetone layer will change the vacuum attachment energy of an HMX crystal surface. Therefore, the modified attachment energy was calculated by $E'_{\text{att}} = E_{\text{att}} - E_{\text{s}}$. As shown in Table 4, the modified attachment energy (E'_{att}) of (011) is lowest, only $-31.56 \text{ kJ} \cdot \text{mol}^{-1}$. The order of modified attachment energy for different crystal surfaces is: (011) > (10–1) > (110) > (101) > (020). Therefore, the (011) face has great morphological importance for its slowest growth rate. Due to their fast growth rate, the (020) and (101) faces will disappear in the final crystal morphology of HMX.

Recrystallization of HMX in acetone was carried out. After recrystallization in acetone, the phase transition of β -HMX crystal did not happen.³⁷⁻⁴¹ The crystal morphology of HMX before recrystallization is shown in Figure 7, the crystal morphology of HMX after recrystallization in Figure 8(a) and the predicted morphology is shown in Figure 8(b). The predicted morphology has a good consistency with SEM of HMX, both have a large (011) plane and the area ratio of each crystal is highly consistent. This suggests that accuracy and



Figure 7. The crystal morphology of HMX before recrystallization.

reliability of using the original HMX structure and the attachment energy model to predict crystal growth morphology are high, in which the crystal surface roughness has been taken into account.

3.4 Sensitivity

Before recrystallization, the HMX crystal morphology is irregular and the particle size is variable. After recrystallization, the HMX crystal morphology is structured, polyhedron-shaped with a smooth surface. To study the influence of the recrystallization and crystal morphology on the sensitivity of HMX, the friction sensitivity and impact sensitivity of the samples before and after recrystallization were compared.

Before recrystallization, the shape and size of HMX crystals are irregular. The edges and sharp corners of the crystals are clear. In addition, due to the defect energy caused by the crystal defects, the crystals are more active. Thus, the sensitivity of the HMX before recrystallization

 Table 6.
 Crystal growth parameters of HMX crystal habit faces in acetone.

Solvent	(h k l)	E_{int}	A _{acc}	$A_{\rm box}$	$E_{\rm s}$	$E_{\rm att}^\prime$	$R'_{\rm hkl}$
Acetone	(011)	-544.82	115.58	782.28	-80.51	-31.56	1.00
	(110)	-754.74	134.55	851.34	-119.30	-48.03	1.52
	(020)	-481.54	65	434.27	-72.06	-90.16	2.86
	(10-1)	-1070.96	143.32	865.70	-177.32	-45.10	1.43
	(101)	-982.42	129.12	1081.37	-117.29	-72.73	2.30

All energies are in kJ·mol⁻¹; distances are in Å.



(a) SEM of HMX

(b) predicted morphology

Figure 8. The crystal morphology of HMX after recrystallization.



Figure 9. Sensitivities of two HMX samples. HMX1 and HMX 2 correspond to the crystals before and after recrystallization from acetone.

is high. After recrystallization, the crystal shape is a polyhedron and nearly-perfect. According to Bowden's hot spot theory,⁴² crystals with smooth surfaces can effectively reduce the risk of hot spots formed under mechanical force. In addition, the crystallographic perfection has a great effect on the sensitivity of explosive crystal. While the crystals are perfect and compact, the internal defects are few. In that case, there will be few hot spots, and the mechanical sensitivity is naturally lower than that of the HMX before recrystallization. As shown in Figure 9, recrystallization in acetone can effectively reduce the sensitivity of HMX, especially the impact sensitivity. After recrystallization, the impact sensitivity of HMX can be reduced from 92 to 64%, a reduction of 28%. These results effectively demonstrate that the sensitivity of explosives can be reduced by improving crystal morphology by recrystallization in acetone.

4. Conclusions

HMX single crystal was prepared and structure obtained. The attachment energy (AE) model was applied to predict the crystal morphology of HMX. Both the morphology and sensitivity of HMX before and after recrystallization were characterized. Specific conclusions are as follows: (4) HMX single crystal structure with R factor of 0.35 was obtained. The structure is different from the HMX crystal structures commonly used, which could be related to particle size effects, orientation of the HMX crystals and the test conditions. (2) The morphologically dominant faces are (011), (110), (020), (10-1) and (101). The order of binding of acetone on different surfaces of HMX is as follows: (10-1)>(101)>(110)>(011)>(020). Crystal surfaces inter act with acetone layers mainly via van der Waals force, besides part electrostatic and other forces. (3) The (011) face is morphologically important for its slowest growth rate; (020) and (101) faces disappear in the final crystal morphology of HMX. (4) The predicted morphology is consistent with the SEM result. (5) Recrystallization in acetone can effectively reduce the sensitivity of HMX, especially the impact sensitivity.

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